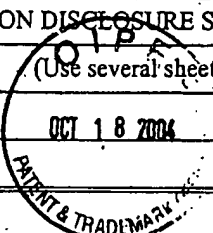


U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-10697 US		09/697,025	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					MEHRDAD NIKOONAHAD ET AL.			
					Filing Date		Group	
					October 26, 2000		2623	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
35	AA	6,023,338	2/8/2000	Bareket	356	401	7/12/96	
	AB							
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	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
28	AQ	"Microinterferometre differentiel a ondes polarises," G. Nomarski, <i>J. Phys Radium</i> 16, (S-13S (1955))						
15	AR	"Lithography Process Control," H. Levinson, <i>SPIE press</i> , Vol. TT28, Bellingham, Washington, 1999						
	AS							
Examiner		Date Considered 3/5/03						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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